

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Goro NAKATANI et al.)	Confirmation No.: 4701
)	
Application No.: 10/043,276)	Group Art Unit: 2811
)	
Filed: January 14, 2002)	Examiner: Junghwa M. Im
)	
For: SEMICONDUCTOR DEVICE AND)	Mail Stop Amendment
METHOD FOR MANUFACTURING)	
THE SAME)	

Mail Stop Amendment
Commissioner of Patents
U.S. Patent and Trademark Office
Alexandria, VA 22314

Sir:

AMENDMENT

In response to the Office Action dated December 24, 2009, the period for response to which extends through March 24, 2010, please amend the above-identified application as follows: